

<b>Notice of References Cited</b>	Application/Control No. 10/812,765	Applicant(s)/Patent Under Reexamination ARAI ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0063824	05-2002	Ha et al.	349/113
*	B	US-2003/0160914	08-2003	Ha, Kyoung-Su	349/106
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	K	US-			
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	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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